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PATENT
Atty. Docket No. SNS-006C?1
(7268/10)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Shih et al.
SERIAL NO.: 09/347,637 **GROUP NO.:** 2671
FILING DATE: July 6, 1999 **EXAMINER:** E. L. Santiago
TITLE: SYSTEMS AND METHODS FOR SCULPTING VIRTUAL OBJECTS IN A HAPTIC VIRTUAL REALITY ENVIRONMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

AMENDMENT AND RESPONSE

This paper is responsive to the Office Action mailed from the United States Patent Office on November 29, 2001, in the above-identified patent application. Applicants respectfully request that the amendments and remarks that follow be considered, and that the rejections made in the Office Action be withdrawn. Applicants believe that the appropriate fee is submitted herewith, but if any additional fee is due, the Commissioner is hereby authorized to charge any such fee to Deposit Account No. 20-0531.

In accordance with 37 C.F.R. 1.121(c), Applicants submit herewith separate sheets presenting each amended claim in marked up form showing all the changes relative to the previous version of the claim, as well as a clean version of all claims pending in the application.

A Petition for a one-month Extension of Time to Respond, up to and including Friday, March 29, 2002, and the appropriate fee therefor are submitted herewith. The appropriate fee for two (2) new dependent claims is also submitted herewith.

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